

U.S. Particle Accelerator School Education in Beam Physics and Accelerator Technology



Elettra Sincrotrone Trieste

Layout Definition for e-Beam Diagnostics

S. Di Mitri (90min.)

Prologue

- e-Beam diagnostics is a vast and multi-disciplinary field, and necessarily interfacing with e-beam dynamics (a dedicated international conference, IBIC, is devoted to this field only).
- We will limit to the interplay of beam dynamics and diagnostic resolution power, skipping details on the diagnostic hardware (which is assumed to do what we expect it does...)
- For reason of space, we will limit to some of the most common diagnosis techniques, and discuss their impact on the machine layout.
- \Box In the following, we will consider measurement of:
- mean energy,
- energy spread,
- bunch length,
- transverse emittance

Mean Energy ~ Spectrometer



* How to proceed:

- 1. geometry of the ref. trajectory (θ , R) is fixed by the mechanical assembly;
- 2. B_y is chosen to center the *beam* onto the detector (screen or BPM);
- 3. calculate $\langle p_z \rangle$.

Measurement errors:

- trajectory distortion before/after the dipole magnet,
- dipole field calibration errors (vs. the supplying current),
- misalignment of the dipole/detector.

Typical error is of at ~1 MeV level, at energies higher than 10s of MeV.

Energy Spread ~ Spectrometer

Average over the beam particle ensemble:

$$\langle p_z^2 \rangle = \langle p_z \rangle^2 + \langle p_z \rangle^2 \frac{\langle \Delta x^2 \rangle}{\eta_x^2}; \Rightarrow \sigma_E = \langle E \rangle \frac{\sigma_x}{\eta_x}$$

- * The measurement of σ_{E} depends on the value of $\eta_{\text{x}}.$ This can be measured in turn as follows:
 - 1. change the beam mean energy (by a few %),
 - 2. look at the variation of beam centroid position on the detector,
 - 3. apply a polynominal fit to the curve $\Delta x(\delta)$; the linear term is η_x .



Energy Resolution

The beam spot size at the screen is the sum of the geometric (betatron) and chromatic (dispersive) particle motion:

$$\sigma_x = \sqrt{\varepsilon_x \beta_x + \eta_x^2 \sigma_\delta^2}$$

The energy resolution due to the beam geometric optics (for an infinite screen resolution) is:

In reality, the finite screen resolution (millimeter per pixel) can be neglected if it is smaller than the geometric beam size:

EXERCISE: assume $\sigma_{screen,res}$ = 30 µm/pixel, $\gamma \varepsilon_x$ = 1 mm mrad at 100 MeV, η_x = 1.5m. Evaluate β_x at the screen to ensure $\sigma_{E,res}$ = 10keV. Is it large enough to overcome $\sigma_{screen,res}$?

Impact on the Layout Design DIPOLE **SCREEN** these affect both Bx and Nx **BPM**

these affect only β_x

- > Make η_x large to minimize $\sigma_{E,res}$
- \Rightarrow large bending angle (typically > 20deg) \Rightarrow add quadrupoles after the dipole
- > Make β_x small to minimize $\sigma_{E,res}$

 \Rightarrow use quadrupoles after the dipole \Rightarrow use quadrupoles before the dipole

- \succ For any given screen resolution, make β_{\star} larger to increase the beam size \Rightarrow tune the **ratio** $\sqrt{\beta_x}/\eta_x$ to keep $\sigma_{E,res}$ fixed
- □ A BPM soon after the dipole can be easily used for the mean energy measurement, being less sensitive to trajectory distortion occurring between the dipole and the screen.
- □ A SCREEN at the line end takes advantage of the maximum dispersion and optics tuning. It is devoted to the energy spread measurement.

USPAS June 2015



How to proceed:

- vary φ_{RF} and measure $\langle \Delta y_{S} \rangle$, then fit the curve to compute the "optics calibration factor" **B** = $eV_{\perp}R_{34}/E$ [mm/rad];
- now measure $\sigma_{y,s}$ and evaluate the bunch length as $\sigma_z = \sigma_{y,s} / B$;

Bunch Length Resolution

* Beam non-zero transverse emittance and residual z-y correlations (e.g., by transverse wakefield) affect the calibration curve, thus the σ_z resolution.



If we assume no net wakefield effect, the bunch length resolution due to the beam geometric optics (for an infinite screen resolution) at the zero-crossing RF phase is:
finite emittance beam

pencil beam

$$\sigma_{z,res} = \frac{\sigma_{y,S}}{T_{RF}R_{34}} = \frac{p_z c \sqrt{\varepsilon_y}}{eV_\perp k_{RF} \sqrt{\beta_D} |\sin \Delta \psi_{DS}|}$$

* In practice, V_{\perp} and $\beta_{y,S}$ should be large enough to ensure $\sigma_{y,S}$ >> $\sigma_{screen,res}$.

USPAS June 2015

S. Di Mitri - Lecture_Th10

 \mathbf{Z}

SCREEN



- > Make $\beta_{y,D}$ large to minimize $\sigma_{z,res} \Rightarrow$ use quadrupoles before the deflector
- > Make $\Delta \psi_{s,D}$ close to $\pi/2$ to minimize $\sigma_{z,res} \Rightarrow$ use quadrupoles, possibly after the deflector.
- > Make $\beta_{y,s}$ large to dominate over $\sigma_{screen,res} \Rightarrow$ use quadrupoles, possibly after the deflector.
- □ Two BPMs at the deflector edges can be used for beam steering onto the deflector electric axis, thus for a correct setting of the RF phase.
- □ A SCREEN at the end of the diagnostic line is devoted to the bunch length measurement.

Projected Emittance ~ Quadrupole Scan



1. The transport matrix from quadrupole (thin lens approximation) to detector (screen) is assumed to be known: $T = QS = \begin{pmatrix} S_{11} + KS_{12} & S_{12} \\ S_{21} + KS_{22} & S_{22} \end{pmatrix}$

 $Q \cong \begin{pmatrix} 1 & 0 \\ K & 1 \end{pmatrix} S = \begin{pmatrix} S_{11} & S_{12} \\ S_{21} & S_{22} \end{pmatrix}$ 2. The beam matrix transforms according to $\Sigma_f = T \Sigma_0 T^t$

 The beam matrix element <x²> is quadratic in the quadrupole integrated strength, K := kl



- $egin{aligned} & arsigma_{11}(=\langle x^2
 angle) = (S_{11}{}^2arsigma_{11_0} + 2S_{11}S_{12}arsigma_{12_0} + S_{12}{}^2arsigma_{22_0}) \ & + (2S_{11}S_{12}arsigma_{11_0} + 2S_{12}{}^2arsigma_{12_0})K + S_{12}{}^2arsigma_{11_0}K^2 \end{aligned}$
- 4. In practice: vary the quad strength k and measure σ_x at the screen. Then fit with a parabola: $\Sigma_{11} = A(K-B)^2 + C$ $= AK^2 - 2ABK + (C + AB^2)$
- Emittance and the Twiss parameters from the fitting coefficients:

$$\epsilon_{m{x}} = \sqrt{AC}/S_{12}^2 \qquad eta_{m{x}} = rac{\Sigma_{11}}{\epsilon} = \sqrt{rac{A}{C}} \qquad lpha_{m{x}} = -rac{\Sigma_{12}}{\epsilon} = \sqrt{rac{A}{C}} \left(B + rac{S_{11}}{S_{12}}
ight)$$

Projected Emittance ~ Multiple Screens, Fixed Optics

- 1. Multiple beam size mesurements are now done with fixed quadrupole strength, but at different locations (multi-screen).
- 2. The beam size at screen 1...n-th transforms according to:



3. Determine vector o by minimizing the sum (least square fit):



Twiss Parameters – Optics Matching

PRSTAB 15 012802 (2012)



Transverse Phase Space ~ Multiple Screens

- Force the beam phase space rotating along the diagnostic line. Look at different screens (fixed optics) or vary a quadrupole's strength.
- Collect all phase space projections onto the spatial coordinate (projected beam size). Then apply the *MENT algorithm* to reconstruct, for the given transport matrix, the phase space at the source point.
- In general, tomographic reconstruction is as accurate as many experimental points are used. But, redundancy is avoided as the phase space is sampled at different rotation angles. Minimum reconstruction error is for 45° phase advance between samples.



USPAS June 2015

S. Di Mitri - Lecture_Th10





> At leats one quad + one screen, for the "quad-scan".

- More quads can be tuned simultaneously to make the scan in one plane while the beam size is mantained almost constantin the other (multi-quad scan).
- By adding at least two more screens, e.g. at 60° phase advance => "multiple screens - fixed optics", without touching the optics for beam production.
- With "mutiple screens", the emittance measurement is less sensitive to erros with (at least) 4 screens at 45° phase advance. This would also permit "phase space tomography" with four points, at fixed optics.
- □ BPMs near quadrupoles allow the beam to be centered into the magnets, so avoiding trajectory steering when the strengths are varied.
- □ Beam size detectors can be either metallic targets (e.g., ~100µm thick Yttrium Aluminum Garnet target producing visible fluorescence, or ~10µm thick Aluminum foil producing Optical transition Radiation). Alternatively, wire scanners ed to intercept the beam.

USPAS June 2015

S. Di Mitri - Lecture_Th10

Longitudinal Phas





USPAS June 2015

S. Di Mitri - Lecture_Th10

Slice Emittance, Slice Energy Spread

RF V-deflector + beam goes straight:



RF V-deflector + H-bent beam:

Quad-scan is applied to the stretched beam. The image is then sampled and the emittance is computed for each slice.

□ The slice energy spread is dominated by the RF curvature (x-E correlation) at the bunch edges, and by the optics resolution in the core.



Pictures courtesy S. Spampinati et al.

RF Deflector-Induced Energy Spread

□ A time-varying transverse magnetic field B_x for deflection implies an off-axis longitudinal electric field $E_z \propto r$ (Panofsky-Wenzel theorem).

RF DEFLECTOR (MAGNETIC)



 \Box Why do particles sample $E_z(y)$ off-axis?

- They travel off-axis due to non-zero beam size and divergence.
- They are (vertically) displaced by *deflection* inside the cavity.

Estimate of Beam Heating

 \Box For an <u>RMS beam size</u> $\sigma_{y} = \sqrt{\beta_{y,D} \varepsilon_{y}}$, the previous equation gives:

$$\sigma_{\delta,\beta} \cong \dots = -\frac{eE_{z,0}k_{RF}\cos\varphi_{RF}}{p_z c} \frac{1}{L} \int_0^L ds \int_0^{s'} ds' \sqrt{\beta_{y,D}} \varepsilon_y \cong -\frac{eE_{z,0}k_{RF}\cos\varphi_{RF}}{p_z c} \frac{1}{L} \cdot \frac{L^2}{2} \cong \left(\frac{eV_{RF}k_{RF}\cos\varphi_{RF}}{p_z c}\right) \frac{\sqrt{\beta_{y,D}}\varepsilon_y}{2}$$

□ For a cavity length L, we obtain:



Other Diagnostic Elements (BC Region)

A dispersive region (BC) allows to profit of diagnostics for time, energy and transverse beam characterization, both on-line and invasive.



✓ BPhM = Bunch PHase (Arrival) Monitor,

 \rightarrow e-beam arrival time respect to the machine clock. On-line $\rightarrow \frac{arrival time}{jitter feedback}$.

 \rightarrow When used before and after a chicane, it gives the beam time-delay across it.

✓ E-BPM = Energy-Beam Position Monitor,

 \rightarrow e-beam mean energy. On-line \rightarrow <u>energy-feedback</u>.

✓ Wire Scanner (alternatively, YAG/OTR screen),

 \rightarrow beam energy spread. Invasive.

✓ Collimator (or Scraper),

 \rightarrow in the presence of a linear t-E correlation (energy chirp), it selects <u>longitudinal bunch slices</u>, to be characterized downstream with <u>no need of a</u> <u>deflector</u>.

✓ CRM = Coherent Radiation Monitor,

 \rightarrow bunch length variation. On-line \rightarrow <u>bunch length (peak current) feedback</u>.

Summing Up



- 1. Mean energy
- 2. Energy spread
- 3. Quadrupole scan
- 4. Transverse tomography

- 5. Bunch length 9. Slicing
- 6. Slice transverse emittance
- 7. Slice energy spread
- 8. Geometric collimation

Summing Up



Trajectory Steering (1-to-1)



□ Look for an optimum distance L_{opt} ($\Delta \mu_{k\beta} = \pi/2$) that minimizes the steerer's kick θ , for any given displacement x at the end:

$$\Delta \mu_{kb} \approx \frac{s_k - s_b}{\overline{\beta}} \quad \blacksquare \quad L_{opt} = \frac{\pi}{2} \,\overline{\beta}$$

□ Now consider a quadrupole magnet in between:



□ In reality, spatial constraints force to compromises:

- A BPM too close to steering magnets makes the correction largely inefficient - poor sensitivity to trajectory control.
- A BPM too far from steering magnets leads to poor reconstruction of the beam trajectory - poor correction.

Trajectory Sampling

E -0.

۳, ۲

-0.2

-0.3

 $\left(\right)$

USPAS June 2015

2

4

6

8

 $\psi_{\rm x}$ (rad)



(u

∧ ∨

∧ × ∨

4 BPMs per β -period can sample and reconstruct the trajectory.

Over-sampling may lead to:

- improvement of the correction sensitivity,
 - \rightarrow weaker corrector strengths
- redundancy (degeneracy),
 - \rightarrow stronger corrector strengths

Optimize the correctors and BPMs layout with codes.

